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TITION FOR EXTENSION OF	TIME UNDER 37 CF	R 1.136(a)	Docket Number	0756-2256	
CERTIFICATE OF MAILING	In re Application of	Koichiro TA	NAKA	-	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to	Number	09/774,637 Filed February 1, 2001			
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on G.G. O4.	BEAM HOMOGENIZER, LASER IRRADIATION For APPRATUS, SEMICONDUCTOR DEVICE, AND METHOD OF FABRICATING THE SEMICONDUCTOR DEVICE				
,	Group Art 2815 Unit			J. Diaz	
This is a request under the provision for filing a reply in the above identified.) to extend the	e period		
The requested extension and appr (check time period desired):	• •	y fee are as f	ollows	•	
☐ One month (37 CFR 1	.17(a)(1)) - (\$55/\$110)			\$	
☐ Two month (37 CFR 1.17(a)(2)) - (\$210/\$420) \$					
Four month (37 CFR 1		•		\$ \$	
Applicant claims small entity st shown above is reduced by on	atus. See 37 CFR 1.2	7. Therefore	, the fee amo	•	
A check in the amount of the fe	ee is enclosed.				
☐ Payment by credit card. Form	PTO-2038 is attached	l.			
The Commissioner has alread Deposit Account.	y been authorized to c	harge fees in	this applicati	on to a	
The Commissioner is hereby a or credit any overpayment, to lidualicate copy of this sheet.					
I am the applicant/inventor			•		
	of the entire interest. der 37 CFR 3.73(b) is			/96).	
	of record.				
	under 37 CFR 1.34(a). umber if acting under 3		a)		
WARNING: Information on thi be included on this form. Prov					
		2		•	
6-9-04 Date	_		Signature	9	
			obinson, Rec	<u>a. No. 38,285</u> d name	
NOTE: Signatures of all the inventors or a Submit multiple forms if more than one sign			eir representativ	e(s) are required.	

Total of forms are submitted.